TSMC 00-085

Application no. 09/633,644

July 10, 2003

ny 10, 2003

TO:

Commissioner of Patents

P.O. Box 1450

Alexandria VA 22313-1450

FROM:

Stephen Ackerman Reg. No. 37,761

28 Davis Avenue

Poughkeepsie, N.Y. 12603

SUBJECT:

Serial #

09/633,644

File Date:

08/07/2000

Inventor:

Hsaio, Yu-Kung, et al.

Examiner:

Kang, Donghee

Art Unit:

2811

Title:

High Transmittance Overcoat For Optimization of

Long Focal Length Microlens Arrays In

Semiconductor Color Imagers

RESPONSE TO FINAL OFFICE ACTION

This is in response to the Office Action dated 06/25/2003 Please amend the above identified application for patent as follows:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to : Commissioner of Patents, P.O. Box 1450, Alexandria VA 22313-1450 on

Signature Opt. 25, 2003

Stephen B. Ackerman, Reg. No. 37,761

Soot 25, 2003.

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Application no. 09/633,644

Application No.

09/633,644

Confirmation No.

Applicant

Hsaio, Yu-Kung, et al.

File

08/07/2000

TC/A.U.

2811

Examiner

Kang, Donghee

Docket No.

TSMC 00-085

Customer No.

1 51410 00-002

Commissioner of Patents P.O. Box 1450 Alexandria VA 22313-1450

AMENDMENT

Sir:

In response to the Office action of 06/25/2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 14 of this paper.

Remarks/Arguments begin on page 21 of this paper.

An Appendix including a product brochure is attached following page 26 of this paper.